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1	The Pacerwork Reduction Act of 1995, no se	Application Number	10/615,051			
	TRANSMITTAL	Filing Date	July 7, 2003			
i	FORM	First Named Inventor	Brian A. Vaartstra			
	(to be used for all correspondence after initial filing)	Art Unit	2812	•		
		Examiner Name	Unknown			
	Total Number of Pages in This Submission	Attorney Docket Number	MI22-2308			

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This collection of information is required by 37 CFR 1.5. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to 12 minutes to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the including case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES CR. COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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DEC 0 5 2003 EN IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application Serial No	
Filing Date	
Inventorship	
Assignee	Micron Technology, Inc.
Group Art Unit	
Examiner	Unknown
Attorney's Docket No	MI22-2308
Title: Methods of Forming a Phosphorus Do and Methods of Forming Trench Isol Circuitry	

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References - See Attached Form PTO-1449

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. Copies of the cited art are attached hereto. No admission is made regarding whether all the submitted references are prior art.

This Supplemental Information Disclosure Statement is being filed within three months of the filing date of the application or before the mailing of a first Office Action on the merits, whichever occurs last. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this Supplemental Information Disclosure Statement, please charge the fee specified under 37 C.F.R. § 1.17(p) to Deposit Account No. 23-0925.

Respectfully submitted,

Dated: 12/5/0

Mark S. Matkin

Reg. No. 32,268

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Form PTO-1449

U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

ATTY. DOCKET NO. MI22-2308

SERIAL NO. 10/615,051

LIST OF ART CITED BY APPLICANT

(Use several sheets if necessary)

APPLICANT: Brian A. Vaartstra

FILING DATE July 7, 2003 GROUP 2812

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*Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate		
:	AA	10/655,699		Derderian et al.			09/05/2003		
	AB								
	AC								
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	AJ								
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OTHER RE	FEREN	ICES (including Author,	Title, Date, Pe	ertinent Pages, Etc.)					
	АМ	Hausmann et a	al., "Catalytic v	apor deposition of highly conformal silica r	nanolamin	ates", Depa	artment of		
	Chemistry and Chemical Biology, Harvard University, May 14, 2002, pp. 1-13.								
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